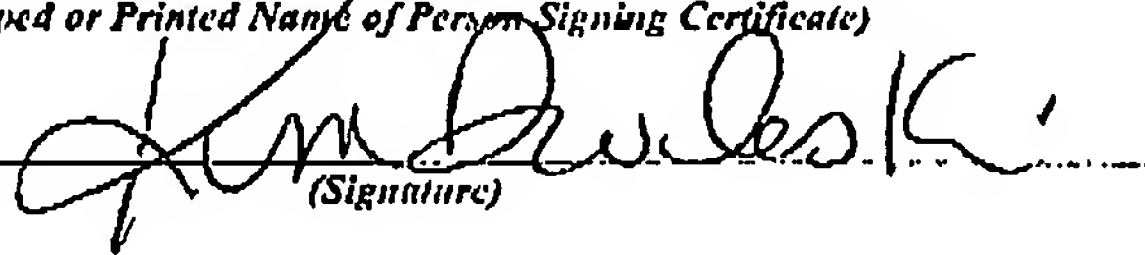


<b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>			<b>Docket No.</b> BUR920040122US1
Applicant(s): Cline et al.			
<b>Application No.</b> 10/711,953	<b>Filing Date</b> 10/15/2004	<b>Examiner</b> Chen, Eric Brice	<b>Group Art Unit</b> 1765
<b>Invention: DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION</b>			
			<b>RECEIVED</b> <b>CENTRAL FAX CENTER</b> <b>DEC 05 2005</b>
<p>I hereby certify that this <u>Request for Reconsideration (14 pages)</u> (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u>) on <u>12/5/2005</u> (Date)</p>			
<p>Kim Dwileski (Typed or Printed Name of Person Signing Certificate)  (Signature)</p>			
<p>Note: Each paper must have its own certificate of mailing.</p>			

**DEC 05 2005**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Cline *et al.*

Examiner: Chen, Eric Brice

Serial No.: 10/711,953

Art Unit: 1765

Filed: 10/15/2004

Docket No.: **BUR920040122US1**

**Title: DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Request for Reconsideration**

Sir:

This Request for Reconsideration is in response to the Office Action mailed September 7, 2005.